

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AF  
8723  
JW

Applicant: Paul A. Farrar

Title: CHEMICAL MECHANICAL POLISHING SYSTEM AND PROCESS

Docket No.: 1303.018US1

Filed: August 30, 2001

Examiner: Maurina Rachuba



Serial No.: 09/944,983

Due Date: June 23, 2005

Group Art Unit: 3723

**MS AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

☒ A return postcard.

☒ An Amendment and Response Under 37 CFR 1.116--Expedited Procedure (23 Pages).

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By: Marvin L. Beekman  
Atty: Marvin L. Beekman  
Reg. No. 38,377

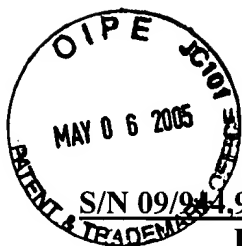
CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 4 day of May, 2005.

KACIA LEE  
Name

Kacia Lee  
Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



**EXPEDITED PROCEDURE – EXAMINING GROUP 3723**

**S/N 09/944,983**

**PATENT**

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**AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Final Office Action mailed March 23, 2005, please amend the application as follows: